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Application Number		10764345		
Filing Date		2004-01-23		
First Named Inventor	Tie Liu			
Art Unit		3685		
Examiner Name	Dante Ravetti			
Attorney Docket Number		MS1-1811US		

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	1	6134343		2000-10-17		Nichani			
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	1	20040125983	A1	2004-07-01		Reed, Alastair	M.; et al.		
	2	20040249615	A1	2004-12-09		Grzeszczuk, F	Radek; et al.		
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	1	JP2000115728;(A)	2000-04-21 SONY CORP				
	2	RU2193825;(C2)	KTORSKOE BJURO VYCHISLITEL NYK;				
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	1	Bebis et al., "Using Algebraic Functions of Views for Indexing-Based Object Recognition", Sixth International Conference on Computer Vision, Bombay, India, January 4-7, 1998, pp. 634-639.					
	2	Cooper et al., "Summarizing Popular Via Structural Similarity Analysis", 2003 IEEE Workshop on Application of Signal Processing to Audio and Acoustics, New Paltz, NY, October 19-22, 2003, pp. 1-4.					
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